## MAILED

JUN 172002

## **Technology Center 2600**

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant:

SUMIKAWA, et al.

Appl. No.:

09/782,180

Filed:

February 14, 2001

For:

SEMICONDUCTOR DEVICE AND METHOD OF

MANUFACTURING THE SAME

onf.:

Group: 2814

Examiner: D. NGUYEN CENTER 2800

THOD OF SUPPLEMENTAL TO THE INFORMATION DISCLOSURE STATEMENT FILED MAY 22, 2002

Assistant Commissioner for Patents Washington, DC 20231

June 13, 2002

PATENT

0033-0694P

Sir:

Supplemental to the Information Disclosure Statement filed on May 22, 2002, attached are copies of partial English translations for DE19740055A1 and WO99/26287. These translations are provided for the Examiner's convenience and recently became available.

If the Examiner has any questions concerning the IDS, he/she is requested to contact the undersigned. If it is determined that the IDS has been filed under the wrong rule, the PTO is requested to consider the IDS under the proper rule and charge the appropriate fee to Deposit Account No. 02-2448.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. § 1.16 or under § 1.17; particularly, extension of time fees.

Respectfully submitted,

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CG/EAG/lab 0033-0694P

Enclosures: partial English translations